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Notice of Allowability	Application No.	Applicant(s)	
	10/033,100	YAMAZAKI ET AL.	
	Examin r	Art Unit	
	Renee R Berry	2818	
Th MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	olication. If not include will be mailed in due	ed course. THIS
 This communication is responsive to <u>10/23/03</u>. The allowed claim(s) is/are <u>9,10 and 22-33</u>. The drawings filed on <u>25 October 2001</u> are accepted by the 			
 4. ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) ☐ All b) ☐ Some* c) ☐ None of the: 			
1. Certified copies of the priority documents have been received.			
2. Certified copies of the priority documents have been received in Application No			
 Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). 			
* Certified copies not received: 5. Acknowledgment is made of a claim for domestic priority use reference was included in the first sentence of the specification (a) The translation of the foreign language provisional as	ation or in an Application Data Sheet	onal application) since . 37 CFR 1.78.	a specific
6. Acknowledgment is made of a claim for domestic priority up in the first sentence of the specification or in an Application	nder 35 U.S.C. §§ 120 and/or 121 si	nce a specific referen	ce was included
Applicant has THREE MONTHS FROM THE "MAILING DATE" of below. Failure to timely comply will result in ABANDONMENT of	this communication to file a reply contribution this application. THIS THREE-MOI	omplying with the requ NTH PERIOD IS NOT	irements noted EXTENDABLE.
7. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
 8. CORRECTED DRAWINGS (as "replacement sheets") mus (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No. (b) including changes required by the proposed drawing c (c) including changes required by the attached Examiner's 	on's Patent Drawing Review (PTO-	en approved by the E	
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the margin according to 37 CFR 1.121(d).			
9. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT FOR T	sit of BIOLOGICAL MATERIAL r HE DEPOSIT OF BIOLOGICAL MA	must be submitted. I TERIAL.	Note the
Attachment(s)			
1 ☐ Notice of References Cited (PTO-892)	5☐ Notice of Informal Pa	itent Application (PTO	-152)
 2 Notice of Draftperson's Patent Drawing Review (PTO-948) 3 Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No. 	6 ☐ Interview Summary (7 ☑ Examiner's Amendm		·
4 Examiner's Comment Regarding Requirement for Deposit of Biological Material	8⊠ Examiner's Statemer	nt of Reasons for Allov	vance
David Nelms			
Supervisory Patent Examiner			
Technology Cente: 2600			

EXAMINER'S AMENDMENT

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows: Cancel claims 1-8 and 11-21.

REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance: There is no prior art of record that teaches or suggests a film formation method that includes setting different temperatures to a material plural times to form a purified material by sublimation; and forming a thin film on a substrate using the purified material immediately after the setting step.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Renee R Berry whose telephone number is (571) 272-1774. The examiner can normally be reached on M-F 9-5:30.

RRB

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January 26, 2004

David Nelms
Supervisory Patent Examiner
Technology Center 2800